

	Application No. Applicant(s)		
Notice of Allowability	10/072,931	YAMAZAKI ET AL.	
	Examiner	Art Unit	
	Stanetta D. Isaac	2812	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in) or other appropriate commun RIGHTS. This application is su	this application. If not included nication will be mailed in due co	urse. THIS
1. This communication is responsive to the amendment filed	<u>l on 12/28/06</u> .		
2. X The allowed claim(s) is/are 10,11,13,15,17,19,21,23,25,2	7,29,31,33,35,37,39,41,43,47,	49,51,53,55,57,63,65,67,69,71 <u>,</u>	73 and 77-85.
 3. Acknowledgment is made of a claim for foreign priority unally All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 	re been received. re been received in Application	ı No	. Comba
 Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)). 	ocuments nave been received	in this national stage applicatio	n from the
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be submitted.	MENT of this application. nitted. Note the attached EXA	MINER'S AMENDMENT or NO	
INFORMAL PATENT APPLICATION (PTO-152) which giv	, , ,	declaration is deficient.	
5. CORRECTED DRAWINGS (as "replacement sheets") mu		/ DTO 040\	
(a) ☐ including changes required by the Notice of Draftsper1) ☐ hereto or 2) ☐ to Paper No./Mail Date	-	(P10-948) attached	
(b) ☐ including changes required by the attached Examiner Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in	's Amendment / Comment or	e drawings in the front (not the b	ack) of
DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	osit of BIOLOGICAL MATE	RIAL must be submitted. No	te the
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Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)		ormal Patent Application mmary (PTO-413),	
3. ⊠ Information Disclosure Statements (PTO/SB/08),	Paper No./N	Mail Date Amendment/Comment	
Paper No./Mail Date 12/28/06 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material		Statement of Reasons for Allowa	ance
		MININI MAN	
	SUP	MICHAEL LEBENTRITT ERVISORY PATENT EXAMIL	NER

EXAMINER'S AMENDMENT

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

Applicant has elected claims without traverse in the reply filed on 3/24/03. Therefore, the nonelected species claims, 1-9, 12, 14, 16, 18, 20, 22, 24, 26, 28, 30, 32, 34, 36, 38, 40, 42, 44, 46, 48, 50, 52, 54, 56, 58, 60, 62, 64, 66, 38, 70, 72, 74 and 76, have been cancelled.

REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance:

The closest prior art of record, Yamazaki et al., US Patent 5,789,284 in view of Chan US 6,670,259, fails to show the following steps of:

Pertaining to independent claim 10, "adding a noble gas element to a region of the second semiconductor film; gettering the metallic element into the region of the second semiconductor film to remove or reduce the amount of the metallic element within the first semiconductor film having a crystalline structure;"

Pertaining to independent claim 47, "adding a noble gas element to a region of the second semiconductor film; gettering the material for promoting crystallization into the region of the second semiconductor film."

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Pertaining to independent claim 49, "forming a second semiconductor film over the first semiconductor film, the second semiconductor film comprising a noble gas element; gettering the material for promoting crystallization into the second semiconductor film."

Pertaining to independent claim 67, "adding a noble gas element to a region of the second semiconductor film; gettering the metallic element into the region of the semiconductor film to remove or reduce the amount of the metallic element within the crystalline semiconductor film;"

Pertaining to independent to claim 78, "adding a noble gas element to a region of the semiconductor film; gettering the metallic element into the semiconductor film to remove or reduce the amount of the metallic element within the crystalline semiconductor film."

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Stanetta D. Isaac whose telephone number is 571-272-1671. The examiner can normally be reached on Monday-Friday 9:30am -6:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Lebentritt can be reached on 571-272-1873. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Stanetta Isaac Patent Examiner March 28, 2007

MICHAEL LEBENTRITT
SUPERVISORY PATENT EXAMINED